



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q65550

Hidekazu YAMAZAKI, et al.

Appln. No.: 09/911,394

Group Art Unit: 1732

Confirmation No.: 5074

Examiner: Not Yet Assigned

Filed: July 25, 2001

For: FILM FORMATION METHOD CAPABLE OF PREVENTING FLUCTUATION OF RIBBON

RECEIVED
MAY 08 2003
GROUP 1700

STATEMENT UNDER 37 C.F.R. § 1.97(e)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

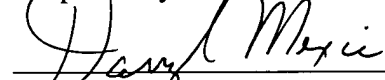
Sir:

The undersigned hereby states, upon information and belief:

That each item of information contained in the Information Disclosure Statement filed concurrently herewith was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of said Information Disclosure Statement.

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Respectfully submitted,


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WASHINGTON OFFICE



23373

PATENT TRADEMARK OFFICE
Date: May 6, 2003